## PATENT APPLICATION TRANSMITTAL LETTER

cc:

(Large Entity)

Docket No.

ITL.0947US (P15971)

## TO THE COMMISSIONER FOR PATENTS

Transmitted herewith for filing under 35 U.S.C. 111 and 37 C.F.R. 1.53 is the patent application of:  Joseph M. Steigerwald  For: Electrochemically Polishing Conductive Films on Semiconductor Wafers							1281 U.S. PTO 10/722801	
Enclosed are:  Certificate of Mailing  1  - A certified copy of a Declaration  Power of Attorney Information Disclose Preliminary Amend Other: Assignmen	sheets of dra a  Signed.  Sure Statement	awings.	el No. EL application.	990 136	5 896 US		312	
		CLAIMS	S FILED				· · · · · ·	
For	#Filed	#Allowed	#Extra		Rate		Fee	
Total Claims	19	- 20 =	0	x	\$18.00		\$0.00	
Indep. Claims	3	- 3 =	0	x	\$86.00		\$0.00	
Multiple Dependent Claims (check if applicable)							\$0.00	
						BASIC FEE	\$770.00	
	-				TOTAL	FILING FEE	\$770.00	
	eby authorized to the control of the control of the control of the control overpayment. It is additional filing the control of	o charge and cro as g fees required u n 37 C.F.R. 1.18	s filing fee. under 37 C.F.F	ccount	No. and 1.17.	20-1504 Ilowance,		
Dated: November 26, 2	2003		Tro 855 Hou (713	p, Prun 4 Katy l Iston, T 3) 468-8	Trop, Regerer & Hu, P. Freeway, Surexas 77024	.C. uite 100		